

Investigation on the Body Bias Dependency of Gate Induced Drain Leakage Current in the Body-Tied finFET

Chul Lee, Makoto Yoshida, Kyoung-Ho Jung, Chang Kyu Kim, Hui-Jung Kim, *Heungsik Park, **Won-Sok Lee, Keunnam Kim, Jaerok Kahng, Wouns Yang, and Donggun Park

Device Research Team, *Process Development Team, **CAE Team, Semiconductor R&D Center, Samsung Electronics
San 24 Nongseo-Dong, Giheung-Gu, Yongin-City, Gyeonggi-Do, 449-711, KOREA
Phone: +82-31-209-3373, Fax: +82-31-209-3274, E-mail: chul69.lee@samsung.com

1. Introduction

A small cell size and low voltage with high-speed operations are necessary for the future DRAM cell transistor. A finFET is one of the candidates [1-4], since it has strong immunity to the short channel effect, the high drain current and the small body bias dependency of threshold voltage (V_{th}) (Fig. 1). However, V_{th} of the finFET is hard to control, since V_{th} is almost decided by a work-function of the gate material. To control V_{th} or an off-leakage current, new gate materials or negative word line (NWL) scheme were adopted, but unfortunately, these methods increase the gate induced drain leakage (GIDL) current and degrades the data retention time of the finFET DRAM [5]. It is well known that optimization of the gate oxide thickness and drain doping profile are necessary to reduce the vertical electric field and GIDL current. Besides, the GIDL depends not only on the vertical electric field but also the lateral electric field [6,7]. Generally, body bias is applied to DRAM cell transistors to reduce the off-leakage current from source to drain by increasing the V_{th} and decreasing the sub-threshold swing (SS). The body-tied finFET has better SS and negligible body bias dependence of V_{th} . Therefore, body bias is unnecessary in the body-tied finFET.

In this paper, we have investigated the body bias dependence of GIDL current in the body-tied finFET, since the body bias affects the lateral electric field. We have found that by reducing the body bias, GIDL current can be reduced, and the lateral electric field can be affected by gate bias in the body-tied finFET.

2. Experiment

Based on the 80nm design-rule, the local damascene (LD) finFET was integrated to avoid passing gate effects [8]. Fig. 2 shows simulation results of passing gate effects, when the passing gate is faced with a storage node through the gate oxide. If a negative bias is applied to the passing gate, GIDL current increases. If the operation bias is applied to the passing gate, V_{th} decreases. Therefore, in both perturbation cases, the off state leakage current is increased.

The field oxide under the word line at the both sides of the fin active is locally etched in the LD finFET structure, as shown in Fig. 3(a). After surface treatment of the fin, a radical oxidation for the gate oxide was followed by the gate poly silicon deposition on the LD patterns. Boron in-situ doped p+ type poly silicon was used as the bottom electrode of the gate. W was, then, deposited and followed by gate stack patterning and ILD deposition. Fig. 3(b) shows the fabricated LD finFET after gate stack formation.

3. Result and Discussion

Unlike SOI finFET, body bias can be applied to the body-tied finFET. The body bias dependence of GIDL current was measured in both drain and gate bias sweep cases. Insets of the Figs. 4 & 5 show that as the drain to body bias (V_{db}) increases, GIDL current increases, even at the same V_{dg} . This phenomenon is understood that the lateral electric field (V_{db}) lowers the tunneling barrier height of the vertical electric field (V_{dg}) [6, 7]. The activation energies of GIDL current as a function of V_{dg} were measured. The increased lateral electric field decreases the activation energies of GIDL current in the high V_{dg} (Fig. 6).

A different slope of GIDL current was observed as a function of V_{db} and V_{gb} at the same V_{dg} . Figs. 7(a) and 7(b) show that the slope of GIDL current at the same V_{dg} are different in the channel accumulation and depletion case. This means that the lateral electric field between drain and body is changed by the gate bias. If the majority carriers in the fin channel are accumulated, the lateral electric field can be fully applied through a neutral region within the fin. Then, the slope can be steeper than that of the depletion case. When the majority carriers in the fin channel are depleted, the lateral electric field is shielded by the depleted body. Therefore the slope of GIDL current is saturated in the depletion region (Fig. 8).

In order to confirm the above assumption, we compared the lateral electric field dependency of GIDL current as a function of V_{gb} at the same V_{dg} . The band to band tunneling current can be expressed as equation (1) in the 3 terminal band to band tunneling current model [7].

$$J \sim \frac{A\psi_s E_{si}}{\eta + E_{si}\xi} \exp\left(-\frac{B + \eta V_d}{E_{si}} + \xi V_d\right) \quad (1)$$

Where $A = (q^3 m_e) / (2\pi^2 \hbar^3)$, $B = (\pi m_e^{1/2} E_g^{3/2}) / (2\sqrt{2} q \hbar)$, ξ is a fitting parameter, and $\eta = (3\pi(m_e E_g)^{1/2}) / (2\sqrt{2} \hbar)$ with the effect mass $m_e = 0.2 m_0$. We compared η and ξ (the lateral electric field dependency of GIDL current). The values of η and ξ as a function of V_{dg} were extracted from the measured data with different bias condition. As V_{dg} increases, the band to band tunneling current dominates the drain leakage current. Therefore, η converges into the theoretical value. The value of ξ decreases as V_{db} increases at the same V_{dg} (Fig. 9). As V_{db} increases, V_{gb} increases at the same V_{dg} . This means that the lateral electric field dependency of GIDL current decreases as V_{gb} increases. It is clear that the lateral electric field dependency of GIDL current is affected by gate bias and the lateral electric field dependency of GIDL current in the channel depletion condition is small compared to the channel accumulation condition.

4. Conclusion

In this paper, the body bias dependency of GIDL current in the body-tied finFET was investigated. GIDL current depends not only on the vertical electric field but also on the lateral electric field. We also found that the lateral electric field dependency of GIDL current in the channel depletion condition is small compared to the channel accumulation condition.

References

- [1] Chul Lee et al., IEDM, Tech. Dig., 2004, pp 61-64.
- [2] R. Katsumata, et al., VLSI, Tech. Dig., 2003, pp 61-62.
- [3] W. Mueller, et al., IEDM, Tech. Dig., 2005, pp 347-350.
- [4] Sung-Woong Chung, et al., VLSI, Tech. Dig., 2006, pp 40-41.
- [5] Chul Lee, et al., IRPS, Proceedings 2006, pp 717-718.
- [6] Kuo-Feng You, et al., TED, Vol. 46, 1999, pp 1174-1179.
- [7] J-H. Chen, et al., TED, Vol. 48, 2001, pp 1400-1405.
- [8] Yong-Sung Kim, et al., IEDM, Tech. Dig., 2005, pp 325-328.

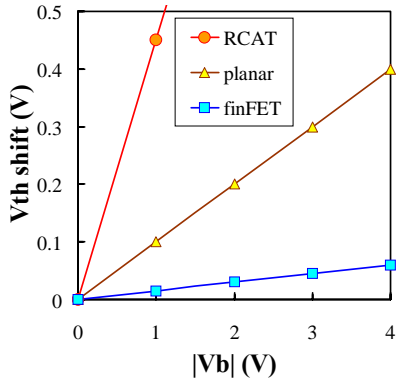
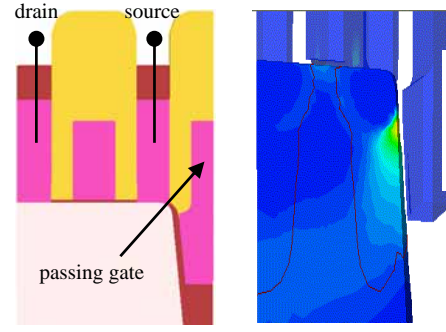


Fig. 1: The V_{th} shift as a function of the body bias with a different structure. A finFET shows negligible V_{th} shift compared to a planar transistor and a recess channel array transistor (RCAT).



(a) simulated finFET

(b) If the operation bias is applied to the passing gate, V_{th} decreases and if the profile (pass gate butting) NWL bias applied to the passing gate, GIDL current increases.

Fig. 2: The simulation result of the passing gate effect. The passing gate induced perturbation increases the off state leakage current.

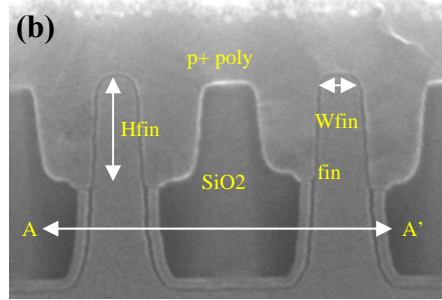
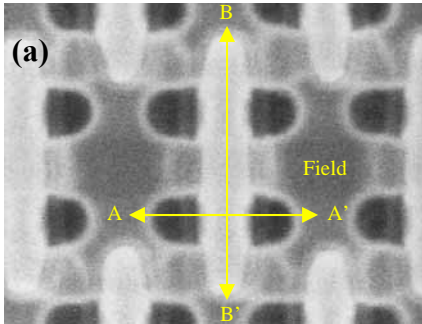
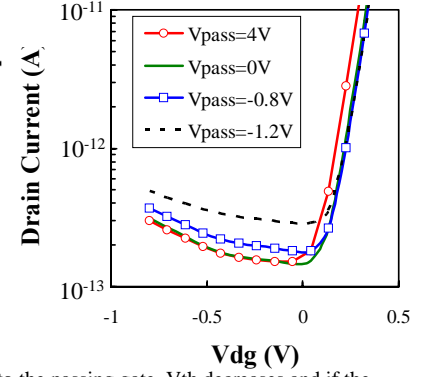


Fig. 3: SEM image of cell array LD finFET before gate oxidation (a) and after gate stack formation (b). The field oxide under the word line at the both side of fin was etched to remove the passing gate effect. The H_{fin} is about 150nm and the W_{fin} of a fin top is about 45nm.

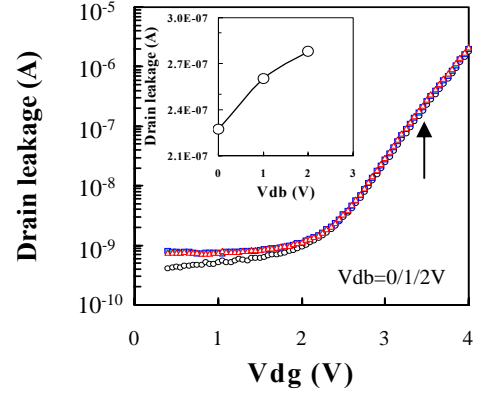


Fig. 4: Drain leakage current as a function of V_{dg} with V_d sweep. Inset shows drain leakage current at $V_{dg}=3.5V$ as a function of V_{db} .

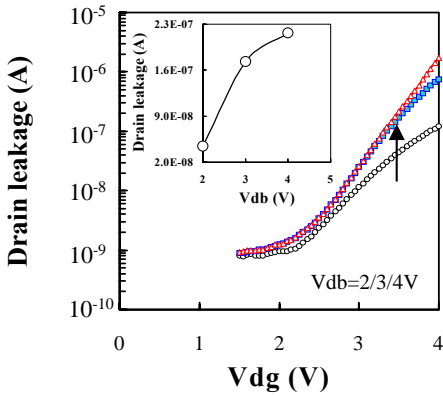


Fig. 5: Drain leakage current as a function of V_{dg} with V_g sweep. Inset shows drain leakage current at $V_{dg}=3.5V$ as a function of V_{db} .

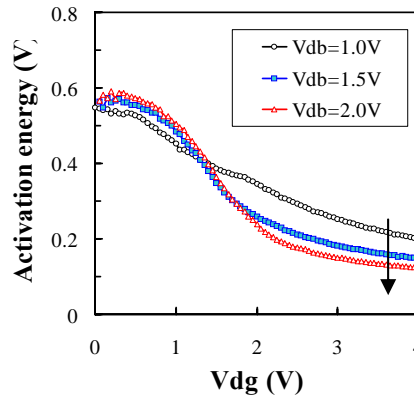


Fig. 6: The activation energy (E_a) of GIDL current as a function of V_{dg} . As V_{db} increases, E_a decreases along the V_{dg} .

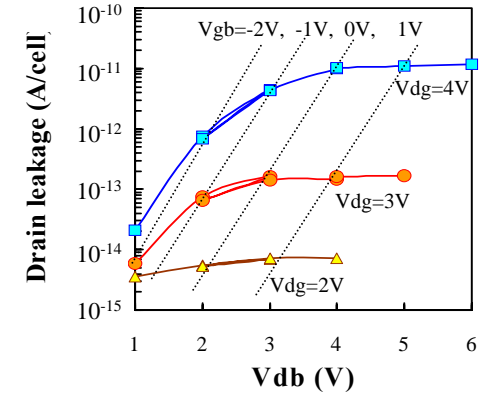


Fig. 7 (a): GIDL current as a function of V_{db} which has different V_{dg} . The slope of GIDL current is steeper in the channel accumulation condition.

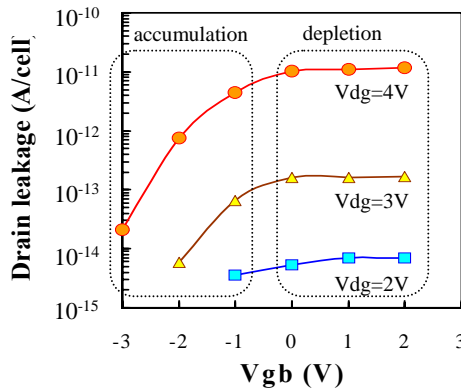


Fig. 7 (b): GIDL current as a function of V_{gb} for different V_{dg} . GIDL current dependency on V_{gb} is steep in the channel accumulation condition.

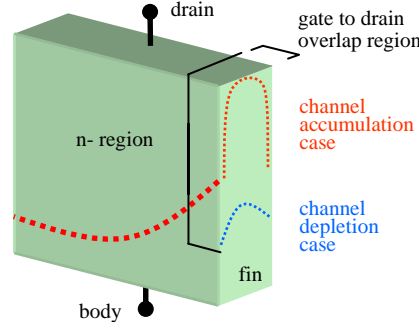


Fig.8: Schematic diagram of the V_g dependent GIDL current in the finFET. The electric field between drain and body varies with V_g . When majority carriers in the fin channel are accumulated, the electric field is fully applied because of the neutral region within the fin.

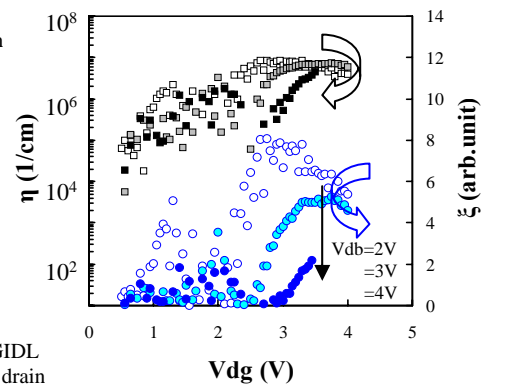


Fig. 9: The lateral electric field dependency of GIDL current (ξ) decreases as V_{db} increases ($= V_{gb}$ increases) at the same V_{dg} .